

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Application No. : 10/510,389 Confirmation No. : 6492
First Named Inventor : Nobuo ISHII
Filed : December 14, 2004
TC/A.U. : 1763
Examiner : DHINGRA, RAKESH KUMAR

Docket No. : 101248.55500US
Customer No. : 23911

Title : Plasma Processing System

AMENDMENT AFTER FINAL UNDER 37 C.F.R. §1.116

Mail Stop AF
Commissioner for Patents
P.O. Box 1450
Alexandria , VA 22313-1450

Sir:

The following proposed amendments and remarks are respectfully submitted in response to the final Office Action dated August 21, 2007. An extension of the deadline for response to the Office Action is respectfully requested pursuant to 37 C.F.R. § 1.136(a) and the appropriate fee is submitted herewith.

Amendments to the Claims are reflected in the listing of claims beginning on page 2 of this paper.

Remarks begin on page 5 of this paper.